



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 10, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG659413558

LABORATORY GROWN DIAMOND

MARQUISE BRILLIANT

10.60 X 5.26 X 3.38 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.09 CARAT

E

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG659413558

PROPORTIONS

Medium To Slightly Thick (Faceted)

16.5%

43.5%

58%

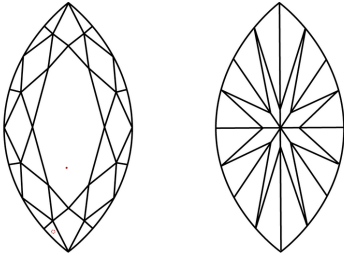
64.3%

Pointed



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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IGI

October 10, 2024

IGI Report No LG659413558

MARQUISE BRILLIANT

10.60 X 5.26 X 3.38 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.09 CARAT

E

VVS 2

64.3%

85%

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG659413558

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